

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
 Stylesheet Version v1.2

EPAS ID: PAT4585756


SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	CHANGE OF NAME
CONVEYING PARTY DATA	
Name	Execution Date
VLSI TECHNOLOGY, INC.	07/02/1999
RECEIVING PARTY DATA	
Name:	Philips Semiconductors VLSI Inc.
Street Address:	1251 Avenue of the Americas
City:	New York
State/Country:	NEW YORK
Postal Code:	10020
PROPERTY NUMBERS Total: 1	
Property Type	Number
Patent Number:	6743679
CORRESPONDENCE DATA	
Fax Number:	(408)518-5671
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>	
Phone:	3474431592
Email:	david.schaeffer@nxp.com
Correspondent Name:	DAVID L. SCHAEFFER
Address Line 1:	411 EAST PLUMERIA DRIVE, MS41
Address Line 2:	NXP SEMICONDUCTORS, IP&L
Address Line 4:	SAN JOSE, CALIFORNIA 95134
NAME OF SUBMITTER:	DAVID L. SCHAEFFER
SIGNATURE:	/David L. Schaeffer/
DATE SIGNED:	09/08/2017
Total Attachments: 3	
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State of Delaware
Office of the Secretary of State PAGE 1

I, EDWARD J. FREEL, SECRETARY OF STATE OF THE STATE OF DELAWARE, DO HEREBY CERTIFY THE ATTACHED IS A TRUE AND CORRECT COPY OF THE CERTIFICATE OF AMENDMENT OF "VLSI TECHNOLOGY, INC.", CHANGING ITS NAME FROM "VLSI TECHNOLOGY, INC." TO "PHILIPS SEMICONDUCTORS VLSI INC.", FILED IN THIS OFFICE ON THE SECOND DAY OF JULY, A.D. 1999, AT 9 O'CLOCK A.M.

A FILED COPY OF THIS CERTIFICATE HAS BEEN FORWARDED TO THE NEW CASTLE COUNTY RECORDER OF DEEDS.




Edward J. Freel, Secretary of State

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AUTHENTICATION: 9846969

DATE: 07-02-99

PATENT
REEL: 018925 FRAME: 0588
REEL: 043533 FRAME: 0080

SECRETARY'S CERTIFICATE

I, Warren T. Oates, Jr., Secretary of Philips Semiconductors Inc., do hereby certify that the attached are a true and correct copy of

1. Certificate of Amendment of Certificate of Incorporation of VLSI Technology, Inc. as filed with the State of Delaware on July 2, 1999 reflecting the change of name of VLSI Technology, Inc. to Philips Semiconductors VLSI Inc.;
2. Certificate of Merger of Philips Semiconductors Inc. and Philips Semiconductors VLSI Inc. as filed with the State of Delaware reflecting the merger of Philips Semiconductors Inc. into Philips Semiconductors VLSI Inc. and the change of name of Philips Semiconductors VLSI Inc. as survivor to Philips Semiconductors Inc. Effective January 1, 2000.

IN WITNESS WHEREOF, I have signed my name and affixed the Corporate Seal on November 22, 2006.


Secretary

STATE OF NEW YORK
COUNTY OF NEW YORK

Subscribed and Sworn to Before
me this 22nd day of November, 2006.


Notary Public

JOAN TAYLOR
Notary Public, State of New York
No. 01740078179
Qualified in Nassau County
Certificate Filed in New York County
Commission Expires June 24, 2010

PATENT
REEL: 018925 FRAME: 0589
REEL: 043533 FRAME: 0081

CERTIFICATE OF AMENDMENT
OF
CERTIFICATE OF INCORPORATION

VLSI Technology, Inc., a corporation organized and existing under and by virtue of the General Corporation Law of the State of Delaware, DOES HEREBY CERTIFY:

FIRST: That the Board of Directors of VLSI Technology, Inc., by unanimous written consent of its members, filed with the minutes of the board, duly adopted resolutions setting forth a proposed amendment to the Certificate of Incorporation of said corporation, declaring said amendment to be advisable:

RESOLVED, that the Certificate of Incorporation of this Corporation be amended by changing the first Article thereof so that, as amended, said Article shall be and read as follows:

"FIRST. The name of the Corporation is PHILIPS SEMICONDUCTORS VLSI INC."

SECOND: That in lieu of a meeting and vote of stockholders, the stockholders have given unanimous written consent to said amendment in accordance with the provisions of Section 228 of the General Corporation of the State of Delaware.

THIRD: That the aforesaid amendment was duly adopted in accordance with the applicable provisions of Section 242 and 228 of the General Corporation Law of the State of Delaware.

IN WITNESS WHEREOF, said VLSI Technology, Inc. has caused this certificate to be signed by Paul S. Friedlander, its Vice President and attested by Warren T. Oates, Jr., its Assistant Secretary this 2nd day of July, 1999.

VLSI TECHNOLOGY, INC.

By: 
Vice President

Vice President

ATTEST:


Assistant Secretary

PATENT

RECORDED: 12/15/2006

RECORDED: 09/08/2017

REEL: 018605 FRAME: 0590

REEL: 043533 FRAME: 0082